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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

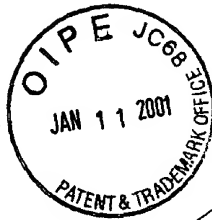
Hideki KOMATSUDA

Application No.: 09/697,639

Docket No.: 105193.01

Filed: October 27, 2000

For: EXPOSURE APPARATUS AND METHOD OF FABRICATION
A MICRO-DEVICE USING THE EXPOSURE APPARATUS



REQUEST FOR CORRECTION OF PALM RECORDS

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Thomas J. Pardini
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OLIFF & BERRIDGE, PLC
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Bib Data Sheet

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|--|---|---------------------------|---|---|
| SERIAL NUMBER 09/697,639 | FILING DATE 10/27/2000 RULE — | CLASS 355 | GROUP ART UNIT 2851 | ATTORNEY DOCKET NO. 105193.01 |
| APPLICANTS Hideki Komatsuda, Kawasaki-shi, JAPAN; | | | | |
| ** CONTINUING DATA ***** THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999 27 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 10-047400 02/27/1998) 27 JAPAN 10-263673 09/17/1998 JAPAN 2000-05137 02/25/2000 056137 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/05/2001 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 21 | TOTAL CLAIMS 46 |
| Examiner's Signature <i>[Signature]</i> Initials | | INDEPENDENT CLAIMS 4 | | |
| ADDRESS Oliff & Berridge PLC P O Box 19928 Alexandria ,VA 22320 | | | | |
| TITLE Exposure apparatus and method of fabricating a micro-device using the exposure apparatus | | | | |
| FILING FEE RECEIVED 1258 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |



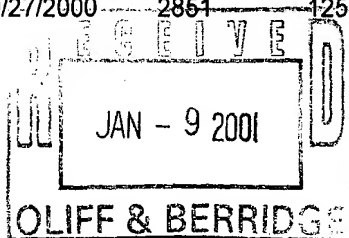
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05193.01

| APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLAIMS | IND CLAIMS |
|--------------------|-------------|--------------|---------------|-----------------|----------|------------|------------|
| 09/697,639 | 10/27/2000 | 2851 | 1258 | 105193.01 | 21 | 46 | 4 |

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FILING RECEIPT



OC000000005658399

Date Mailed: 01/05/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Hideki Komatsuda, Kawasaki-shi, JAPAN;

Continuing Data as Claimed by Applicant

THIS APPLICATION IS A CIP OF 09/259,137 02/26/1999

Foreign Applications

JAPAN 10-047400 02/27/1998
JAPAN 10-263673 09/17/1998
JAPAN 2000-500437 02/25/2000
2000-050137

If Required, Foreign Filing License Granted 01/05/2001

Title

APPARATUS
Exposure apparatus and method of fabricating a micro-device using the exposure apparatus

Preliminary Class

355

Data entry by : NIMMONS, EVELYN

Team : OIPE

Date: 01/05/2001

